

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/649,738	<b>Applicant(s)/Patent under Reexamination</b> CHOI ET AL.
	<b>Examiner</b> Mike Qi	<b>Art Unit</b> 2871

<b>INTERFERENCE SEARCHED</b>			
Class	Subclass	Date	Examiner